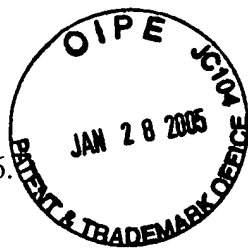


03500.014776



PATENT APPLICATION

1771\$  
JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
HIROKATSU MIYATA ) Examiner: Hai Vo  
Application No.: 09/657,616 ) Group Art Unit: 1771  
Filed: September 8, 2000 )  
For: MESOSTRUCTURED THIN FILM, )  
MESOPOROUS THIN FILM, AND )  
PROCESS FOR PRODUCTION )  
THEREOF ) January 27, 2005

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AND PETITION FOR EXTENSION OF TIME

Sir:

a) Introductory Comments

Applicant petitions to extend the time for response to the Office Action dated October 13, 2004 for one month from January 13, 2005 to February 13, 2005. A check in the amount of \$120.00 to cover payment of the extension fee is enclosed. Please charge any additional fee required for the extension, and credit any overpayment, to Deposit Account 06-1205.

In response to the Official Action dated October 13, 2004, kindly amend the subject application as follows: